

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fulton et al.

Application No.: 10/783,249

Filed: 02/19/2004

Title: PROCESS AND APPARATUS FOR
REMOVING RESIDUES FROM
SEMICONDUCTOR SUBSTRATES

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) Art Unit: 1762
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) Confirmation No.: 1416
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) Examiner: Nicole R. Blan
) Attorney Docket No.: B-14138
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Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO EXAMINER'S ACTION
Dated 09/12/2007

Dear Commissioner:

In response to the Examiner's Action mailed 09/12/2007, please enter the following amendments and remarks of record.

Amendments to the Specification begin on Page 2 of this Response to Office Action.

Amendments to the Claims are reflected in the listing of claims beginning on Page 3 of this Response to Office Action.

Remarks/Arguments begin on Page 11 of this Response to Office Action.